

# Novel crystalline behaviors of self-catalyst GaAs nanowires on GaAs(001) substrates with thin film masks by molecular beam epitaxy

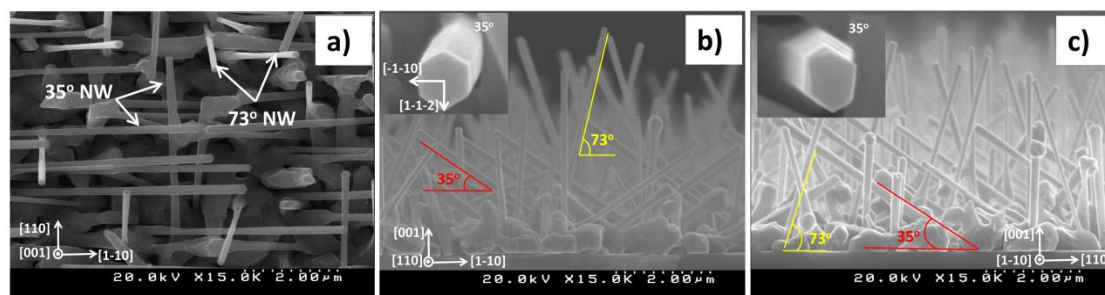
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One-Dimensional (1D) semiconductors have been developed over the last two decades into a large field and they are believed to be building blocks for wide range of applications. III-V group semiconductors are well-known materials with high electron mobility and conductivity that are important for future high-speed and low-power nanoelectronics [1]. Here we present in detail of self-catalyst GaAs nanowire (NW) growth on hydrogen silsesquioxane (HSQ)-coated GaAs(001) substrate using molecular beam epitaxy (MBE).

After coating and annealing of HSQ in the air, substrate surfaces were uniformly covered with 20-nm-thick  $\text{SiO}_x$  which could open pin-holes at the beginning of the growth [2]. Surface treatment is particularly important for NW growth and usually follows complicated procedures. In this work, Ga exposure in 20 s on HSQ-coated substrates without As flux was performed to create NW nucleation sites i.e. Ga nanoparticles. The typical growth condition is as follows; Ga beam equivalent pressure (BEP) of  $5.4 \times 10^{-8}$  Torr (growth rate of 0.04 ML/s on planar), As BEP of  $1.0 \times 10^{-6}$  Torr (V/III ratio of 18.5), and growth temperature of 620 °C.

Figure 1(a) shows top-view scanning electron microscope (SEM) image of NWs after 4-hour growth. To remove Ga nanoparticles at top of NWs, the NWs were kept in As flux of  $2.0 \times 10^{-6}$  Torr at 500 °C for 1 hour without Ga flux. The obtained NWs were found to project on substrate to form approximately 35° and 73° with their own projections  $\langle 1\bar{1}0 \rangle$  and  $\langle 110 \rangle$ , as shown in Figs. 1(b) and 1(c). We also observe that the NWs' cross sections of the all directions show hexagonal shape indicating  $\langle 111 \rangle$  orientations. 35° NWs along  $\langle 1\bar{1}0 \rangle$  are observed to be predominant and attributed to  $\langle 1\bar{1}1 \rangle_B$  orientations. 35° NWs pointing along  $\langle 110 \rangle$  is also evaluated to be  $\langle 1\bar{1}1 \rangle_B$  derived from inverse polarity of crystal through thin and non-polar native oxide layer on substrate. 73° NWs were observed to be  $\langle 1\bar{1}1 \rangle_B$  which are formed through on-substrate rotation of  $\langle 1\bar{1}1 \rangle_B$  by 60° around  $\langle 111 \rangle_A$ . The tendency for 60° rotation around  $\langle 111 \rangle$  on single NW was observed through TEM analysis which enables twin plane formation.



**Figure 1:** GaAs NWs grown by MBE, a) plane view SEM image, b) cross view of  $(1\bar{1}0)$  plane, c) cross view of  $(110)$  plane. The insets of b) and c) show hexagonal cross sections of 35° NWs pointing along  $\langle 1\bar{1}0 \rangle$  and  $\langle 110 \rangle$  respectively.

## Reference

- 1) R. Chau et al., Nat Mater **6** (2007) 810.
- 2) T. Rieger et al., J. Crystal Growth **353** (2012) 39.